

Substitute for form 1449A/PTO				Complete If Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application Number	10/828,885
				Filing Date	April 20, 2004
				First Named Inventor	James S. Clarke
				Art Unit	2813
				Examiner Name	
Sheet	1	of	2	Attorney Docket Number	42P19019

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
tu	2	TOSHIYUKI TOYOSHIA ET AL., 0.1um Level Contact Hole Pattern Formation with KrF Lithography by Resolution Enhancement Lithography Assited by Chemical Shrink (RELACS), Pages 1-3 , Sept of 1998.	
	3	TAKASHI KANDA ET AL., 100nm Contact Holes Using resolution Enhancement lithography Assited by Chemical Shrink, Pages 1-2, Autumn 1999	
	4	VINCENT ARNAL ET AL., Optimization of CVD Dielectric Process to Achieve reliable Ultra Low-k Air Gas, Pages 1-6, 2002	
	5	GINA L. WEIBEL ET AL., An Overview of Supercritical CO2 Applications in Mircroeletronics Processing, Pages 1-8, April 25, 2002.	
	6	ELECTROCHEMICAL SOCIETY, H.J LEE ET AL. , X-Ray Reflectivity and FTIR Measurements of N2 Plasma Effects on the Density Profile of Hydrogen Silsesquioxane Thin Films, Pages1-5, 2001	
tu	7	K MAEX ET AL., Journal of Applied Physics, Low Dielectric Constant Materials for Microelectronics, Volume 93, Number 11, Pages 1-49, June 1, 2003	

Examiner Signature		Date Considered	1/30/06
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*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.

¹Applicant's unique citation designation number. Applicant is to place a check mark here if English language Translation is attached.

Based on PTO/SB/08B (08-03) as modified by Blakely, Solokoff, Taylor & Zafman (wlr) 08/11/2003.
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